



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of

AKITA

Application Number: 09/987,317

Filed: November 14, 2001

**For: SYSTEM VERIFICATION EQUIPMENT, SYSTEM
VERIFICATION METHOD AND LSI
MANUFACTURING METHOD USING THE SYSTEM
VERIFICATION EQUIPMENT**

Attorney Docket No. HITA.0123

**Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231**

Unit 2128

**Examiner
Ferris III, Fred O.**

RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

This is in response to the Office Action mailed on May 11, 2005, the period of response to which is set to expire on September 11, 2005, with a one-month extension fee filed herewith. Please amend the above identified application as follows: